



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 11, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG844653976

LABORATORY GROWN DIAMOND

TRIANGULAR MODIFIED  
BRILLIANT

6.93 X 8.07 X 3.83 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.03 CARAT

D

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

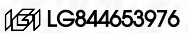
VERY GOOD

VERY GOOD

NONE

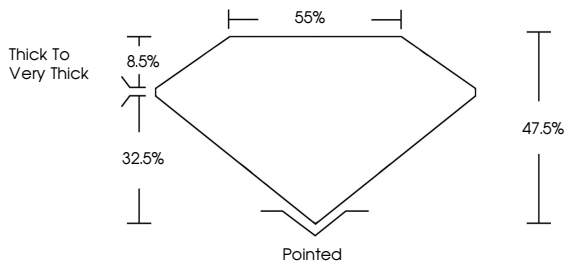
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

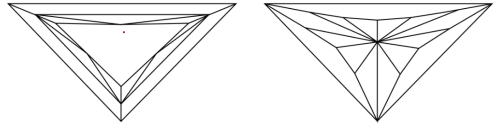


LABORATORY GROWN DIAMOND REPORT

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.



Sample Image Used

COLOR

CLARITY

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



October 11, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG844653976

LABORATORY GROWN DIAMOND

TRIANGULAR MODIFIED  
BRILLIANT

6.93 X 8.07 X 3.83 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.03 CARAT

D

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

VERY GOOD

VERY GOOD

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa





October 11, 2026

IGI Report No LG844653976

TRIANGULAR MODIFIED BRILLIANT

6.93 X 8.07 X 3.83 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Thick to Very Thick

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.03 CARAT

D

VVS 2

47.5%

85%

Thick to Very Thick

Pointed

VERY GOOD

VERY GOOD

NONE

IGI LG844653976

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa